

Attorney Docket # 5367-47RCE

PATENT

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re Application of

Stefan BADER et al.

Serial No.: 10/696,882

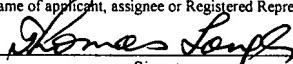
Filed: October 30, 2003

For: Method for Depositing a Material on a Substrate
Wafer

Examiner: RAO, G. Nagesh
Group Art: 1722

I hereby certify that this correspondence is being deposited with the United States Postal Service with sufficient postage as first class mail in an envelope addressed to: Mail Stop Amendment, Commissioner for Patents, P.O. Box 1450, Alexandria, VA 22313-1450, on

May 29, 2007
(Date of Deposit)

Thomas Langer
Name of applicant, assignee or Registered Representative

Signature

May 29, 2007
Date of Signature

Mail Stop Amendment
Commissioner for Patents
P.O. Box 1450
Alexandria, VA 22313-1450

PETITION

Applicant hereby petition(s) for a 1-month extension of the original shortened statutory response period set in the Office Action of January 29, 2007. The Commissioner is hereby authorized to charge the amount of \$120.00 in payment of the government fee for a 1-month extension of time to our Patent and Trademark Office Deposit Account No. 03-2412.

AMENDMENT

SIR:

Responsive to the Office Action dated January 29, 2007, please amend the above-identified application as follows:

Amendments to the Specification begin on page 2 of this paper.

Amendments to the Claims begin on page 3 of this paper.

Remarks/Arguments begin on page 6 of this paper.

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